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DECLARATION FOR TRANSLATION

I, Michie Fuse-Ofuchi , a Patent Attorney, of Ogikubo TM Bldg., 5-26-13, Ogikubo, Suginami-ku, Tokyo 167-0051, Japan, do solemnly and sincerely declare:

That I have a thorough knowledge of Japanese and English languages; and

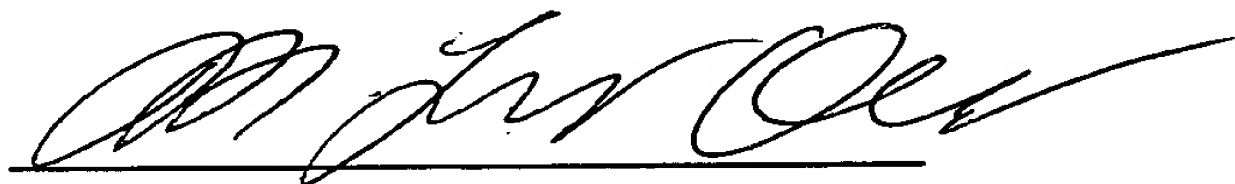
That the attached pages contain a correct translation into English of the Japanese document filed on March 29, 2001 as

U.S. Patent Application No. 09/819,687

entitled "METHOD AND DEVICE FOR MANUFACTURING CERAMICS, SEMICONDUCTOR DEVICE, AND PIEZOELECTRIC DEVICE"

I hereby declare that all statements made herein of my own knowledge are true, and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine and/or imprisonment under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing therefrom.

Date: July /0 , 2001



Michie Fuse-Ofuchi